991765

JUN 0 6 2002

## TRANSMITTAL LETTER (General - Patent Pending)

Docket No. E0520CIP

	•	/ K. T			
1_	Re		1111		A6.
ın	KP /	THOU	IIC 31	מחוי	( )T'
•••		ישטי	TOGI		$\mathbf{v}_{\mathbf{i}}$

Kashmir S. Sahota, Diana M. Schonauer, Johannes F. Groschopf, Gerd F.C. Marxsen, Steven A.

Avanzino

Serial No.

Filing Date

Examiner

Group Art Unit

09/749,191

December 26, 2000

L. Umez-Eronini

1765

"PREVENTION OF PRECIPITATION DEFECTS ON COPPER INTERCONNECTS DURING CMP BY USE SOLUTIONS CONTAINING ORGANIC COMPOUNDS WITH SILICA ADSORPTION AND COPPER CORROSION INHIBITING PROPERTIES"

## TO THE ASSISTANT COMMISSIONER FOR PATENTS:

Transmitted herewith is:

Amendment Transmittal Letter (in duplicate) Amendment an 'Response to Office Action (11 pp) Return Receipt Postcard

in the above identified application.

- $\mathbf{X}$ No additional fee is required.
- A check in the amount of

is attached.

The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No.

01-0365

- as described below. A duplicate copy of this sheet is enclosed.
  - Charge the amount of
  - $\times$ Credit any overpayment.
  - X Charge any additional fee required.

ECENEL TO THE Dated: May 26, 2002

German wenown

Deborah W. Wenocur, Reg. No. 40,221

Agent for Applicant

Advanced Micro Devices, Inc.

Technology Law Dept. M/S 68

One AMD Place

P.O. Box. 3453

Sunnyvale, CA 94088-3453

certify that this document and fee is being deposited on May 23,2002with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C.

Killoan W. Wellen Signature of Person Mailing Correspondence

Deborah W. Wenocur

Typed or Printed Name of Person Mailing Correspondence

CC:

AMENDMENT TRANSMITTAL LETTER (Large Entity) Docket No. Applicant(s): K. Sahota, D. Schonauer, J. Groschopf, G. Marxsen, and S. Avanzino E0520CIP **Group Art Unit** Examiner Filing Date Serial No. L. Umez Eronini 1765 December 26, 2000 09/749,191 Invention: Prevention of Precipitation Defects on Copper Interconnects During CMP by Use of Solutions Containing Organic Compounds with Silica Adsorption and Copper Corrosion Inhibiting Properties TO THE ASSISTANT COMMISSIONER FOR PATENTS: Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below. CLAIMS AS AMENDED **ADDITIONAL** NUMBER EXTRA HIGHEST# **CLAIMS REMAINING** RATE CLAIMS PRESENT **FEE** PREV. PAID FOR AFTER AMENDMENT 0 x \$0.00 \$18.00 73 TOTAL CLAIMS 71 \$0.00 \$84.00 0 x 5 = 5 INDEP. CLAIMS \$0.00 Multiple Dependent Claims (check if applicable) \$0.00 TOTAL ADDITIONAL FEE FOR THIS AMENDMENT COPY OF PAPERS No additional fee is required for amendment.  $\boxtimes$ 

☐ Please charge Deposit Account No.

in the amount of

A duplicate copy of this sheet is enclosed.

A check in the amount of

to cover the filing fee is enclosed.

The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. CAN TO THE A duplicate copy of this sheet is enclosed.

Any additional filing fees required under 37 C.F.R. 1.16.

Any patent application processing fees under 37 CFR 1.17.

Colile Wellen

Dated:

May 26 200

Deborah W. Wenocur, Reg. No. 40,221

Agent for Applicant

Advanced Micro Devices, Inc., Technology Law Dept.

One AMD Place, M/S 68

P.O. Box 3453

Sunnyvale, CA 94088-3453

I certify that this document and fee is being deposited with the U.S. Postal Service as on May 2 x 2002 first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Willyrah W. Weller Signature of Person Mailing Correspondence

Deborah W. Wenocur

Typed or Printed Name of Person Mailing Correspondence

CC: